



PATENT
Customer No. 22,852
Attorney Docket No. 8071.0007

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Takeshi MITSUISHI et al.) Group Art Unit: 2872
Application No.: 09/986,907) Examiner: Joshua Pritchett
Filed: November 13, 2001)
For: COMPOSITION FOR VAPOR) Confirmation No.: 6647
DEPOSITION, METHOD FOR)
FORMING AN ANTIREFLECTION)
FILM, AND OPTICAL ELEMENT)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450
Sir:

REPLY

This is in reply to the Office action mailed April 5, 2005. This reply is being filed with a one-month extension of time and appropriate fee to extend the period of response to August 5, 2005.

Remarks/Arguments follow the amendment sections of this paper.

Attachments to this paper include a petition for a one-month extension of time with fee.